

Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty. Docket No. EBY0003	Serial No.: 10/724,521
	Applicant: Christopher M. Warnock, et al.	
	Filing Date: November 28, 2003	Group: 2624

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Issue Date	Patentee	Class	Sub-class	Filing Date
	1	5,247,575	9/1/1993	Sprague et al.			
	2	5,532,920	07/1996	Hatrick et al.			
	3	6,389,541	5/1/2002	Patterson, Patrick E.			
	4	5,237,157	8/1/1993	Kaplan, Joshua D.			
	5	5,619,247	04/1997	Russo, James			
	6	6,041,316	3/1/2000	Allen, Jonathon Brandon			
	7	6,282,653	8/1/2001	Berstis et al			
	8	6,327,600	12/1/2001	Satoh et al.			
	9	5,991,780	11/1/1999	Rivette et al			
	10	6,920,610	7/1/2005	Lawton et al			
	11	6,119,124	Sep-00	Broder et al.			
	12	6,446,068	Sep-02	Kortge, Chris Alan			
	13	6,988,124	Jan-06	Douceur et al.			
	14	6,606,613	8/12/2003	Altschuler et al.			

U.S. Published Patent Application

Examiner Initial	No.	Document No.	Publication Date	Assignee	Class	Sub-class	Translation	
							Yes	No
	1	2003/185448A1	10/2/2003	Dance, Christopher R., et al.				
	2	2004/0030680A1	2/1/2004	Veit, Daniel				
	3	2003/0037094A1	2/20/2003	Douceur et al.				

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Assignee	Class	Sub-class	Translation	
							Yes	No
	1	EP 0881591	12/2/1998	Stolin				
	2	EP 0881592	12/2/1998	Taylor				
	3	JP 2001175807	6/29/2001	Newman				

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	1	"Geometric Layout Analysis Techniques for Document Image Understanding," January 1998, Review, ITC-IRST Technical Report #9703-09, pp. 1-68, XP002229195, Trento, Italy.
	2	Bartal, "Probabilistic Approximation of Metric Spaces and Its Algorithmic Applications," 1996, In: FOCS Proceedings of the 37th Annual Symposium on Foundations of Computer Science. Washington DC, IEEE, Abstract, pp. 2-3, ISSN 0272-5428.
	3	Zhang, et al., "BIRCH: An Efficient Data Clustering Method for Very Large Databases," 1996, In: ACM Sigmod Record, Proceedings of the 1996 ACM SIGMOD International Conference on Management of Data, New York: ACM Press, Vol.25, Issue 2, pp. 103-14, ISSN 0163-5808.

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.